

DOCKET NO: 273117US0PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
YASUAKI YOKOYAMA, ET AL. : EXAMINER: SHEVIN, MARK L.  
SERIAL NO: 10/542,358 :  
FILED: JULY 14, 2005 : GROUP ART UNIT: 1793  
FOR: COMPOSITION FOR FORMING :  
SILICON-ALUMINUM FILM, SILICON-  
ALUMINUM FILM AND METHOD FOR  
FORMING THE SAME

RESPONSE TO OFFICIAL ACTION DATED SEPTEMBER 23, 2008

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated September 23, 2008, please amend the above-identified application as follows:

**Remarks/Arguments** begin on page 2 of this paper.